



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re the Application of: NAKATA, Yoshihiro et al.

Group Art Unit: 1771

Serial No.: 10/807,174

Examiner: Hai VO

Filed: March 24, 2004

P.T.O. Confirmation No.: 4205

FOR: SILICON-BASED COMPOSITION, LOW DIELECTRIC CONSTANT FILM,
SEMICONDUCTOR DEVICE, AND METHOD FOR PRODUCING LOW
DIELECTRIC CONSTANT FILM

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 28, 2007

Sir:

In response to the Office Action dated November 28, 2006, extended to March 28, 2007 by a one month Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page two of this paper.

Remarks/Arguments begin on page six of this paper.